

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/816,772  
Filing Date ..... April 1, 2004  
Inventor ..... D. V. Nirmal Ramaswamy et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1722  
Examiner ..... Robert M. Kunemund  
Attorney's Docket No. .... MI22-2520  
Title: Methods of Depositing an Elemental Silicon-Comprising material Over a Substrate

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References –See Attached Form PTO/SB/08a

The attached form PTO/SB/08a is submitted in compliance with 37 CFR §1.56. No copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: March 27, 2007

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